



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 30, 2025

IGI Report Number **LG743563947**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **11.93 X 6.82 X 4.32 MM**

GRADING RESULTS

Carat Weight **2.26 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

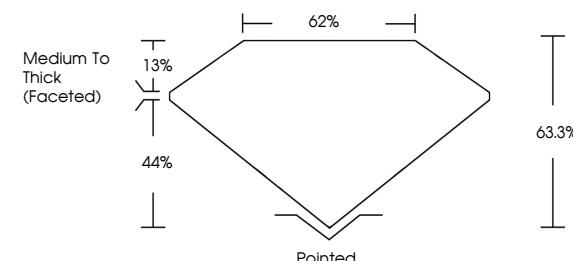
Symmetry **EXCELLENT**

Fluorescence **NONE**

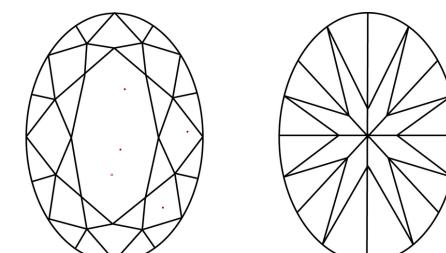
Inscription(s) **IGI LG743563947**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG743563947
Report verification at igi.org

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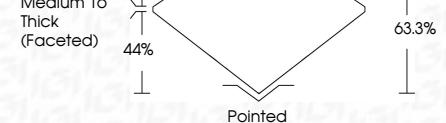
Carat Weight **2.26 CARATS**

E

Color Grade **VVS 2**



Sample Image Used



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Symmetry **EXCELLENT**

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IGI



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October 30, 2025	IGI Report No LG743563947	2.26 CARATS	E	VVS 2	63.3%	62%	Medium To Thick (Faceted)
		Carat Weight	Color Grade	Clarity Grade	Depth	Table Grade	Culet
		11.93 X 6.82 X 4.32 MM					Pointed
							EXCELLENT
							EXCELLENT
							NONE
							IGI LG743563947
							Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa